CLAIM AMENDMENTS

In this Response, Claims 1 and 8 has been amended.

1. (currently amended) An apparatus to support a stent during the process of applying a coating substance to a stent:

a support fixture to support a stent during the application of a coating substance;

a <u>negative</u> pressure system to modify the coating substance applied to the stent supported by the support fixture; and

a coupling element configured to connect one side of the support fixture to the pressure system to allow the support fixture to be rotated with respect to the pressure system.

- 2. (original) The apparatus of Claim 1, wherein another side of the support fixture is capable of being connected to a motor for rotating the support fixture.
- 3. (previously presented) The apparatus of Claim 1, wherein the pressure system is a vacuum device to apply a vacuum pressure to the support fixture.
- 4. (previously presented) The apparatus of Claim 1, additionally including a conduit connecting the coupling element to the pressure system.
- 5. (original) The apparatus of Claim 1, wherein the support fixture includes a component extending into a bore of the stent, wherein the component has an outer surface in contact with an inner surface of the stent.
- 6. (original) The apparatus of Claim 1, wherein the support fixture includes a component extending into a bore of the stent, wherein the component has an outer surface that does not make contact with an inner surface of the stent.
- 7. (previously presented) An apparatus to support a stent during the process of applying a coating substance to a stent:

a coupler;

a support fixture, connected to one side of the coupler, to support a stent during the application of a coating substance to the stent; and

a conduit, in fluid communication with the support fixture, connected to another side of the coupler, wherein the coupler allows the support fixture to be rotated with respect to the conduit.

- 8. (currently amended) The apparatus of Claim 7, wherein the conduit is configured to be connected to a <u>negative</u> pressure system.
- 9. (previously presented) The apparatus of Claim 8, wherein the pressure system is a vacuum device.